

VIA EFS

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Patent Application of:		§	
Takashi ITO, et al.		§	
		§	
Conf. No.:	8148	§	Group Art Unit: 1795
		§	
Appln. No.:	10/562,098	§	Examiner: Anca Eoff
		§	
Filing Date:	December 21, 2005	§	Attorney Docket No.: 9369-114US
		§	(T37-196236C)
Title:	ACTINIC RADIATION –CURABLE STEREOLITHOGRAPHIC RESIN COMPOSITION HAVING IMPROVED STABILITY		

PETITION FOR EXTENSION OF TIME UNDER (37 C.F.R. § 1.136(a))

Applicant(s) in the above-identified application hereby petition(s) for a two-month extension of time to and including July 14, 2008 for responding to the Office Action mailed February 14, 2008. An Amendment accompanies this Petition.

☐ A check in the amount of \$\_\_.00 is enclosed herewith.

☒ The Commissioner is hereby authorized to charge Deposit Account No. 50-1017 (**Billing No. 209369.0114**) as noted below.

☒ Extension fee in the amount of \$460.00

☒ Any deficiencies or overpayments in the above-calculated fee.

Respectfully submitted,  
**Takashi Ito, et al.**

<u>July 14, 2008</u> (Date)	By: <u>/Sandra M. Katz/</u> <b>SANDRA M. KATZ</b> Registration No. 51,864 <b>PANITCH SCHWARZE BELISARIO &amp; NADEL LLP</b> One Commerce Square 2005 Market Street, Suite 2200 Philadelphia, PA 19103-7013 Telephone: 215-965-1330 <b>Direct Dial: 215-965-1344</b> Facsimile: 215-965-1331 E-Mail: <a href="mailto:skatz@panitchlaw.com">skatz@panitchlaw.com</a>
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